

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Attn: APPLICATION BRANCH

Akihisa HONGO et al. : Attorney Docket No. 2003_0979

Serial No. NEW :

Filed July 17, 2003 :

**WAFER CLEANING APPARATUS
(Rule 1.53(b) Divisional
of Serial No. 09/572,432,
Filed May 17, 2000)**

THE COMMISSIONER IS AUTHORIZED
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CLAIM OF PRIORITY UNDER 35 USC 119

Commissioner for Patents
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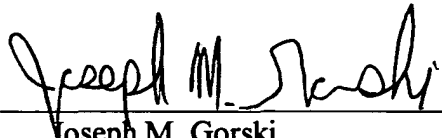
Sir:

Applicants in the above-entitled application hereby claim the date of priority under the International Convention of Japan Patent Application No. 11-139183, filed May 19, 1999, as acknowledged in the Declaration of this application.

A certified copy of said Japan Patent Application is of record in parent application Serial No. 09/572,432, filed May 17, 2003.

Respectfully submitted,

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